



52433/861

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Jiro KONDO, et al.
Serial No. : 10/591,093
Filed : August 29, 2006
For : METHOD FOR REMOVING BORON FROM SILICON
Examiner : Cohen, Stefanie J.
Art Unit : 1793
Confirmation No. : 7884

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on **April 23, 2010**

Signature: Katy Chan-Parsons
Katy Chan-Parsons

AMENDMENT

In response to the Office Action dated February 1, 2010, Applicants respectfully request entry of the following amendments and comments into the file of the above-identified application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.